

Information Disclosure Statement Transmittal

I hereby certify that this transmittal of the below described document is being deposited with the United States Postal Service in an envelope bearing First Class Postage and addressed to the Commissioner of Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on the below date of deposit.			
Date of Deposit:	04/25/05	Name of Person Making the Deposit:	Shannon Carmo
		Signature of the Person Making the Deposit:	<i>Shannon Carmo</i>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): YANG, et al.

Application No.: 10/758,148

Group Art Unit:

Filed: 01/14/2004

Examiner:

Title: EFFICIENT USE OF ~~TRADE~~ AREA WITH DEVICE UNDER THE PAD APPROACH

Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450
Sir:

Information Disclosure Statement Transmittal

Transmitted herewith is the following:

- Formal drawings, totaling sheets.
 Informal drawings, totaling sheets.
 Certification for PTO Consideration
☒ Information Disclosure statement (1 sheets)
 Information Disclosure statement and late filing fee
☒ Form 1449
 Petition for Extension of Time
☒ Other: 5 Foreign References

Fee Calculation (for other than a small entity)

Fee Items	Fee Rate	Total
Petition for Extension of Time (fee calculated elsewhere)	\$.00	\$0.00
Information Disclosure Statement, late filing	\$180.00	\$0.00
Other:		
Total Fees		\$0.00

PAYMENT OF FEES

1. The full fee due in connection with this communication is provided as follows:
- [X] The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to Deposit Account No.: 23-0085.
 A duplicate copy of this authorization is enclosed.

Please direct all correspondence concerning the above-identified application to the following address:

WAGNER, MURABITO & HAO LLP
Two North Market Street, Third Floor
San Jose, California 95113
(408) 938-9060
Customer No: 000045592

Respectfully submitted,

Date: April 25, 2005

By: 

James P. Hao
Reg. No. 36,398



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: AMD-AF01214

Inventor(s): YANG, et al.

Application No.: 10/758,148

Group Art Unit:

Filed: 01/14/2004

Examiner:

Title: EFFICIENT USE OF WAFER AREA WITH DEVICE UNDER THE AD APPROACH

Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Information Disclosure Statement Submitted Pursuant to 37 C.F.R. 1.97(b)

The citations referenced herein, copies attached, may be material to the examination of the above-identified application and are, therefore, submitted in compliance with the duty of disclosure as defined in 37 C.F.R. 1.56. The Examiner is requested to make these citations of official record in the application.

This Information Disclosure Statement submitted in accordance with 37 C.F.R. 1.97(b) is not to be construed as a representation that a search has been made, that additional items material to the examination of this application do not exist, or that any one or more of these citations constitute prior art under 35 U.S.C. 102.

The Examiner's attention is respectfully directed to the following U.S. Patents:

<u>Pat. No.</u>	<u>Pat. Title</u>	<u>Grant Date</u>
5,751,065	INTEGRATED CIRCUIT WITH ACTIVE DEVICES UNDER BOND PADS	05/12/1998

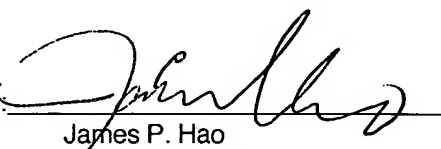
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
Patent Application

Inventor(s): YANG, et al,

Group Art Unit:

Filed: 01/14/2004

Examiner:

Application No.: 10/758,148Conf No.: 4639Title: EFFICIENT USE OF WAFER AREA WITH DEVICE UNDER THE PAD APPROACH

Form 1449

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	5,751,065	05/12/98	CHITTIPEDDI, et al.	257	758	10/30/95
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	L	EP0637840	02/08/95	EPO	H01L	23/485	X	
	M	WO00/35013	06/12/00	PCT	H01L	23/485	X	
	N	JP 332045	11/30/00	JP	H01L	21/60		X
	O	JP 321104	12/12/97	JP	H01L	21/66		X
	P	JP 335627	12/18/98	JP	H01L	27/148		X
	Q							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	
	S	
	T	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered.
Include copy of this form with next communication to applicant.